

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of Koichi TERASHIMA, et al.
Appl. No.: 10/544,783
Confirmation No.: 5339
Filed: August 8, 2005
For: METHOD FOR FORMING NICKEL SILICIDE FILM, METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE, AND METHOD FOR ETCHING NICKEL SILICIDE

Docket No: Q89627
Group Art Unit: 1722
Examiner: Pape A. SENE

RESPONSE TO ELECTION OF SPECIES REQUIREMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

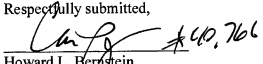
Sir:


This responds to the Election of Species Requirement, dated February 12, 2008. In response to the Examiner's Election of Species Requirement, Applicants elect Species I, Figures 3A and 3B in which claims 1-12, 58 and 59 read. Also, claims 2, 3, 8, 9 and 12 are generic. This Species election is without traverse.

Applicants reserve the right to file Divisional Applications directed to non-elected claims.

The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account.

Respectfully submitted,


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CUSTOMER NUMBER

Date: April 11, 2008